Electronic Patent Application Fee Transmittal									
Application Number:	10694986								
Filing Date:	29-Oct-2003								
Title of Invention:	Method for removing resist pattern and method for manufacturing semiconductor device								
First Named Inventor:	Masaharu Nagai								
Filer:	John F. Hayden/Andrea Turner								
Attorney Docket Number:	12732-171001								
Filed as Large Entity									
Utility Filing Fees									
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)				
Basic Filing:									
Pages:									
Claims:									
Claims in excess of 20		1202	1	50	50				
Miscellaneous-Filing:									
Petition:									
Patent-Appeals-and-Interference:									
Post-Allowance-and-Post-Issuance:									
Extension-of-Time:									

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)	
/liscellaneous:					
Request for continued examination	1801	1	790	790	
	Tota	Total in USD (\$)			